

Design and Simulation of Cantilever Beam with a Bragg Grating based Optomechanical Sensor for Atomic Force Microscopy in COMSOL

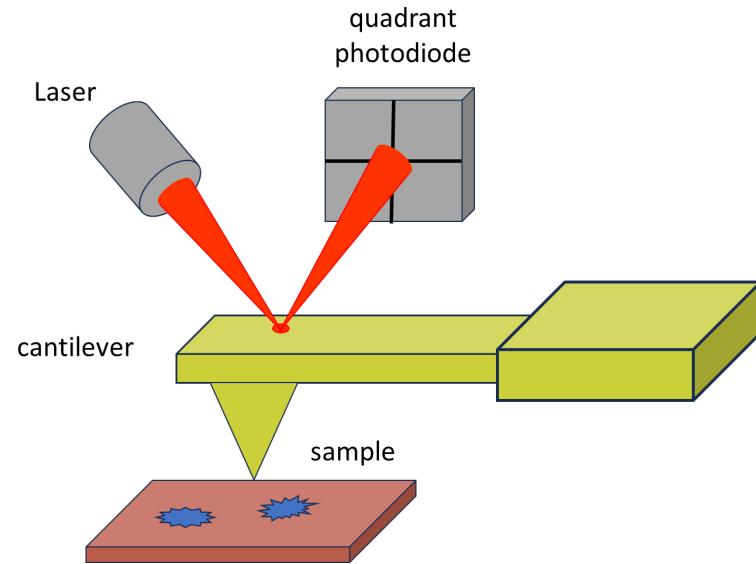
11/13/2023

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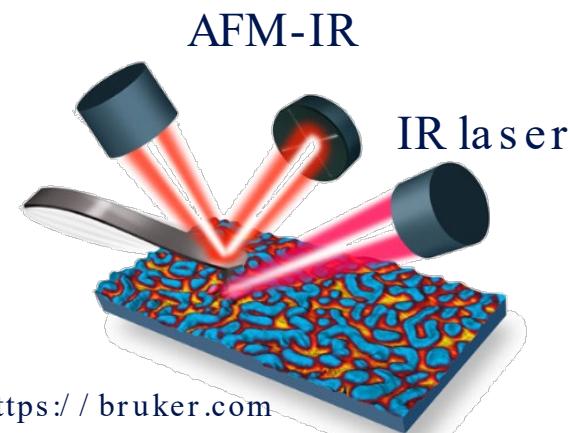
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Atomic Force Microscopy



Advantages:

- High Spatial Resolution
- Non-Destructive
- Force Measurements
- Complementary Technique
- ...

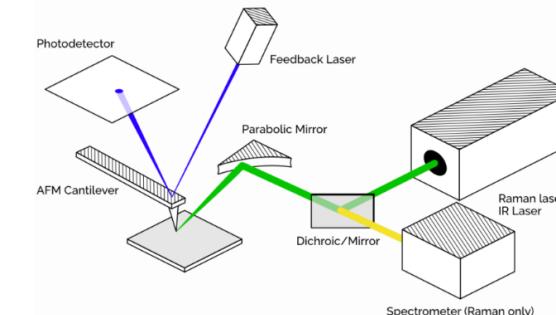


<https://bruker.com>

Disadvantages:

- Slow Scanning Speed
- Tip Wear and Sample Damage
- Deflection laser is an essential component noise and interference
- ...

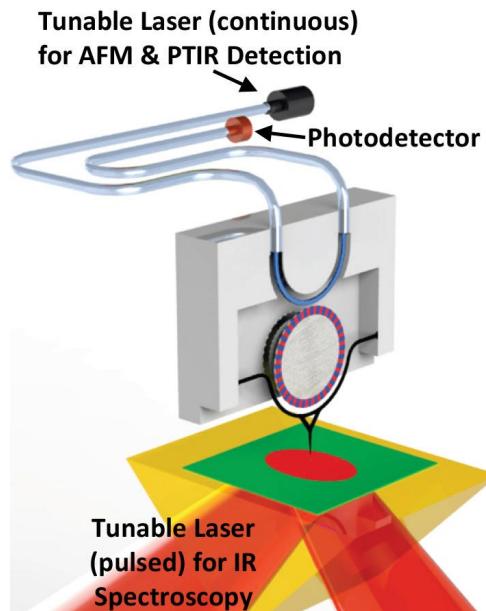
AFM-Raman spectroscopy



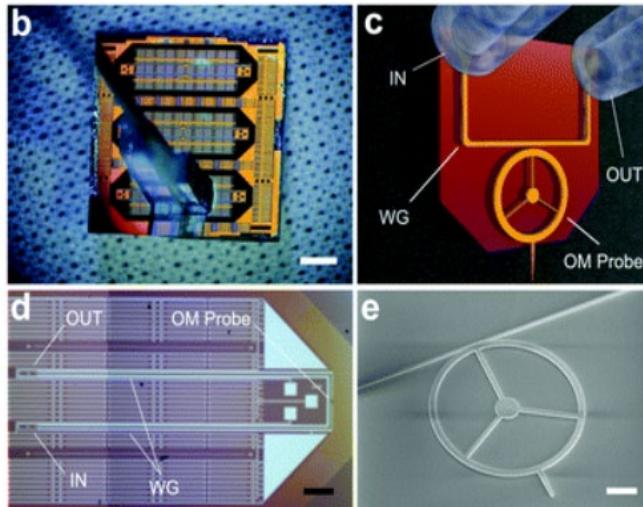
<https://molecularvista.com>

Solution with Silicon photonics:

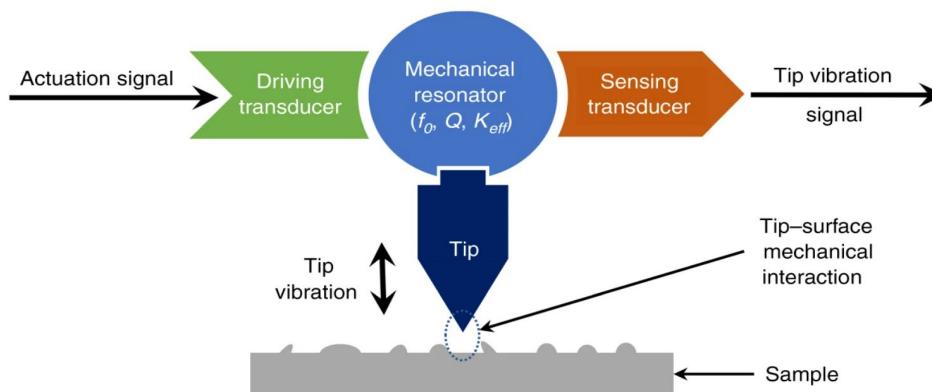
- High scanning speed
- Low-cost
- Compact
- Get rid of deflection laser
- Batch fabrication
- High sensitivity



Andrea Centrone . Nano Lett.
2017,19,9,5587 -5594

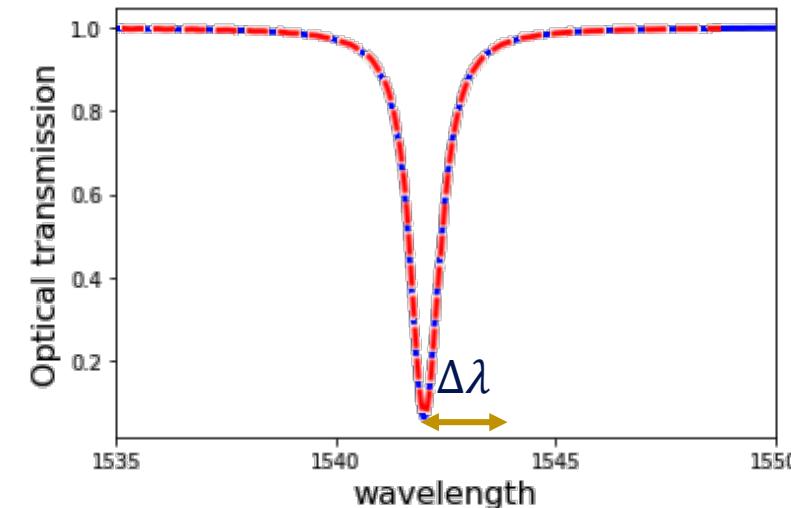


Ivan Favero & Bernard Legrand. Nanoscale,
2020,12,2939 -2945

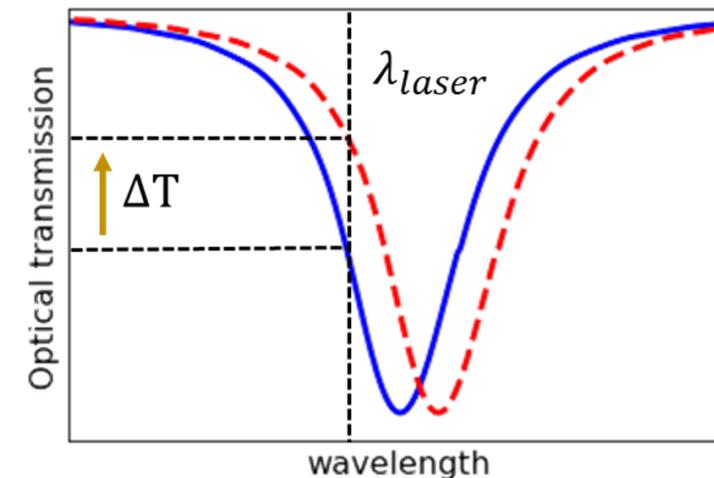


Ivan Favero & Bernard Legrand. Microsyst Nanoeng 8, 32 (2022)

Resonance shift due to cantilever motion

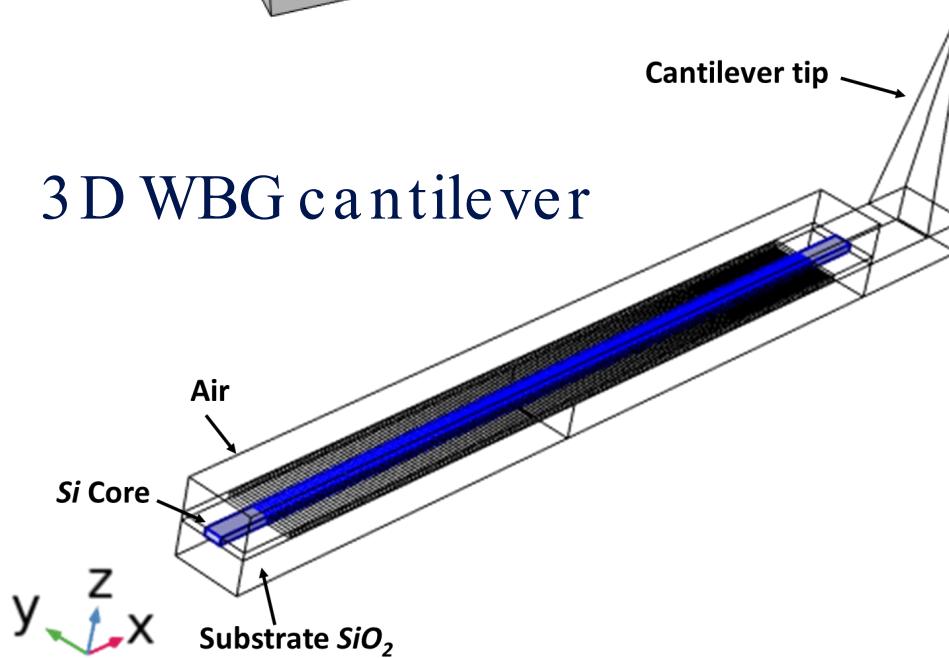
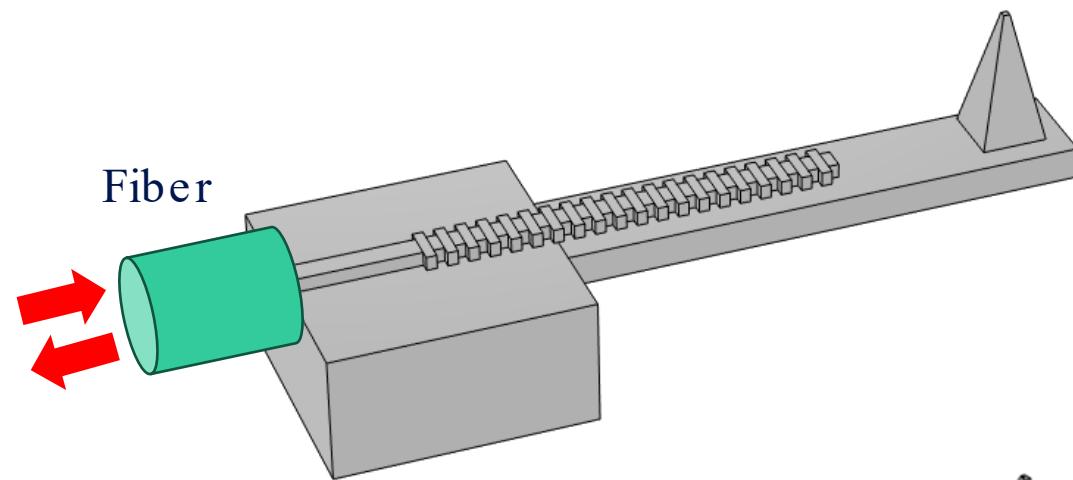
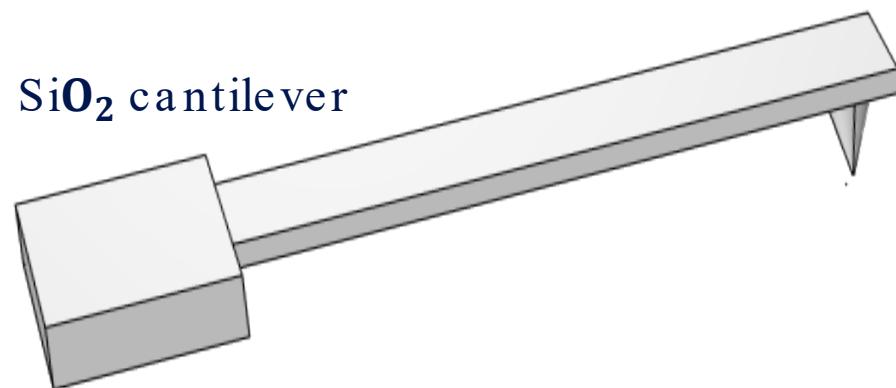
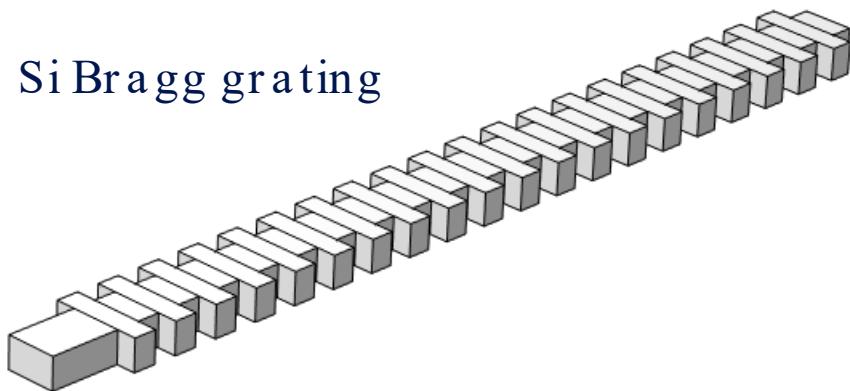


Opt. signal due to cant. motion



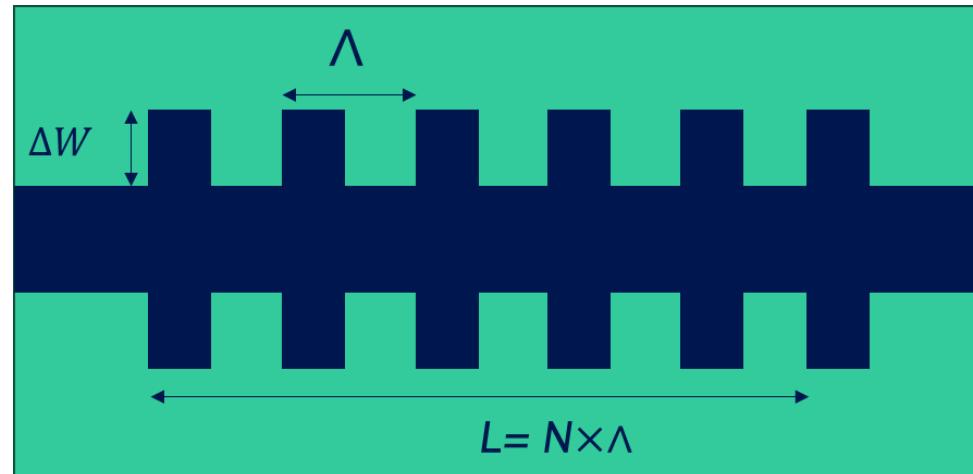
Waveguide Bragg grating (WBG):

- Robust and easy to fabricate
- High-Speed Operation
- Cantilever based



Waveguide Bragg grating (WBG):

- Customized wavelength-selective
- High-Quality Factor (Q-factor)



- ◀ Electromagnetic Waves, Frequency Domain (ewfd)
 - ▶ Wave Equation, Electric 1
 - ▶ Perfect Electric Conductor 1
 - ▶ Initial Values 1
 - ▶ Port 1
 - ▶ Port 2
 - ▶ Scattering Boundary Condition 1

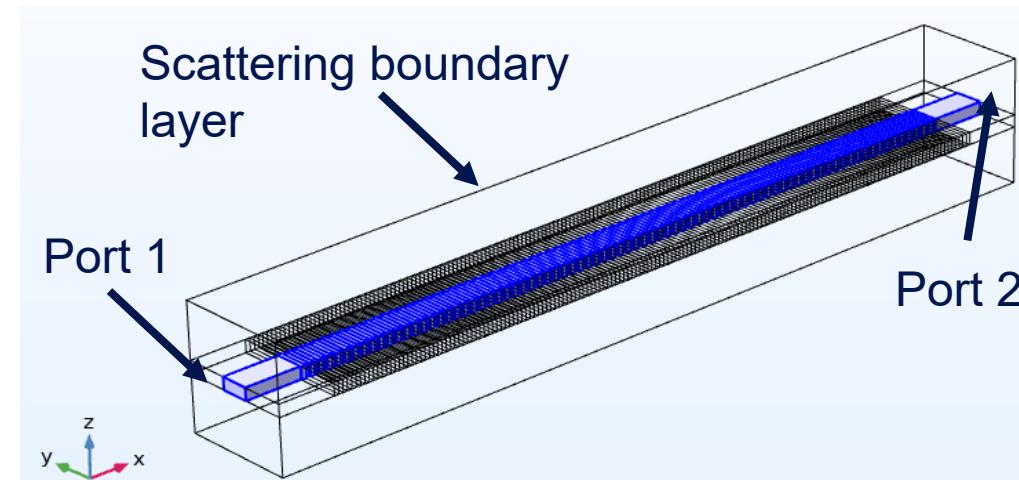
Bragg's equation

$$\lambda_B = 2 \cdot \Lambda \cdot n_{eff}$$

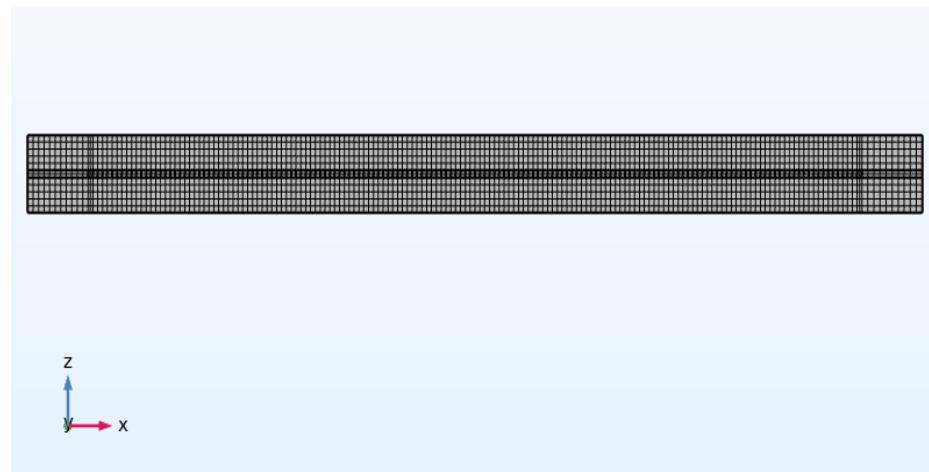
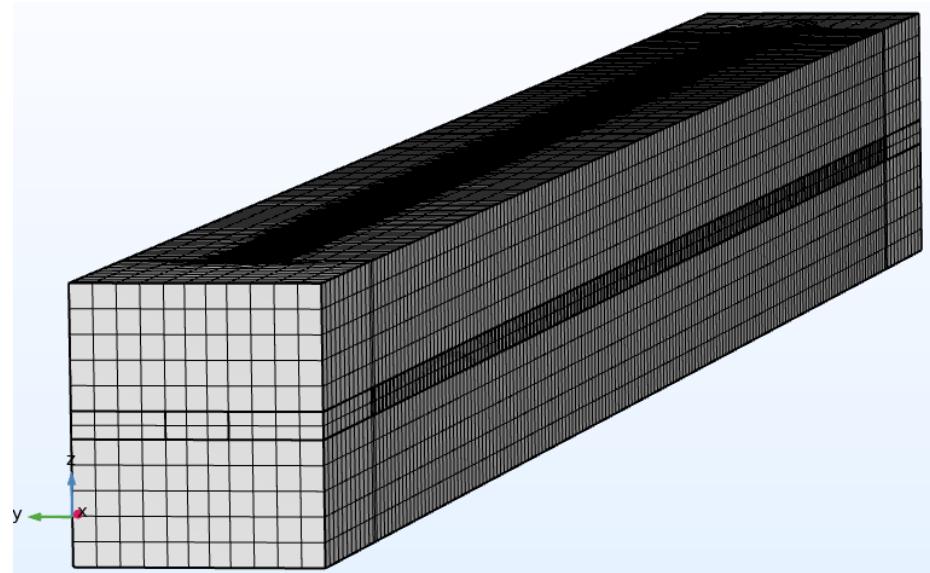
n_{eff} is the effective refractive index.

A resonance shift $\Delta\lambda$ due to the change of refractive index Δn can be expressed by,

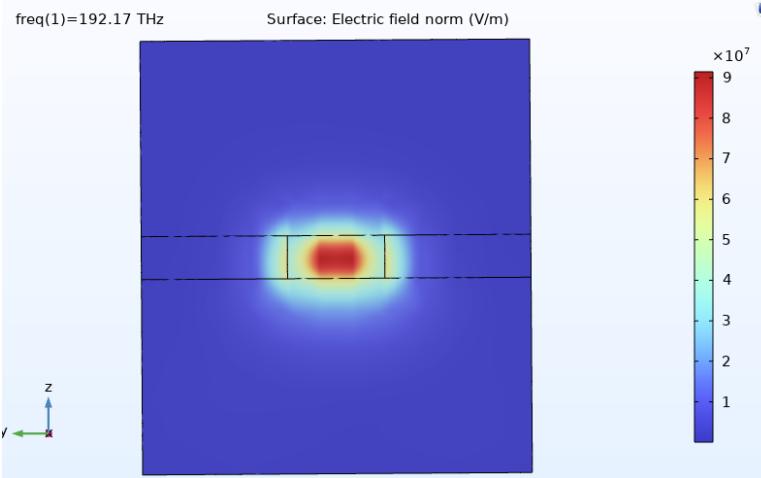
$$\frac{\Delta\lambda}{\lambda} = \frac{\Delta n}{n}$$



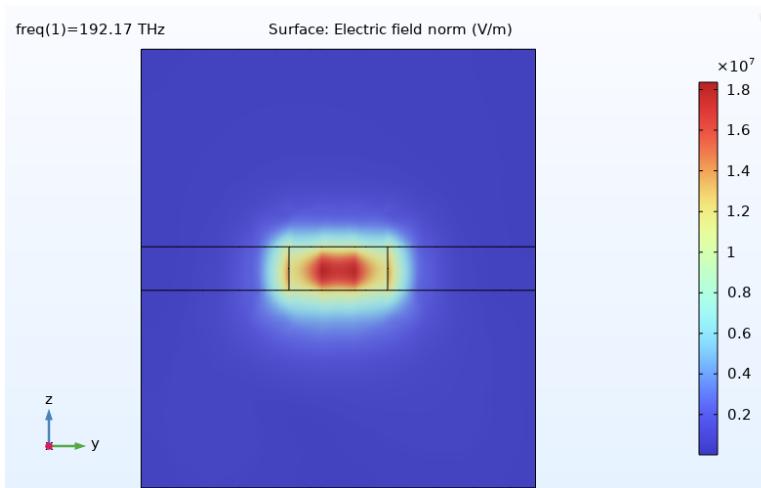
Swept mesh

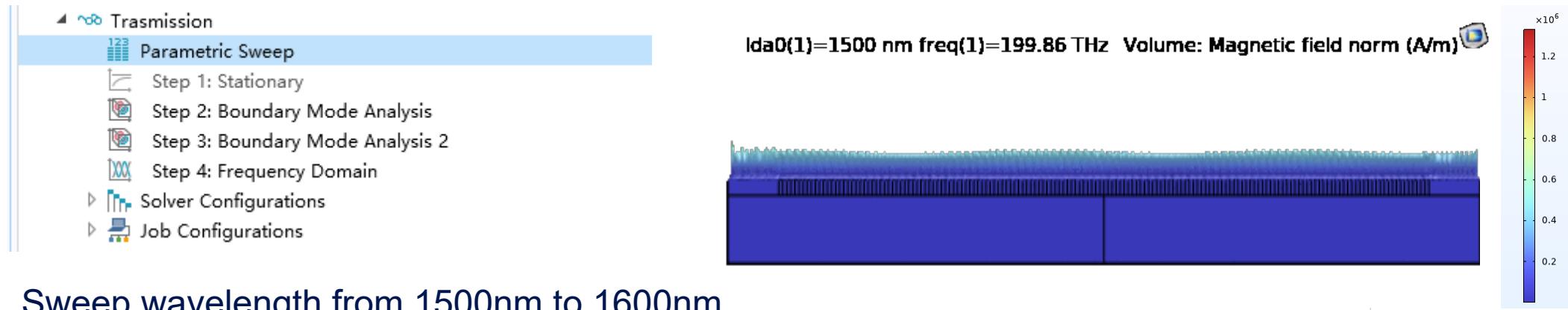


Port 1

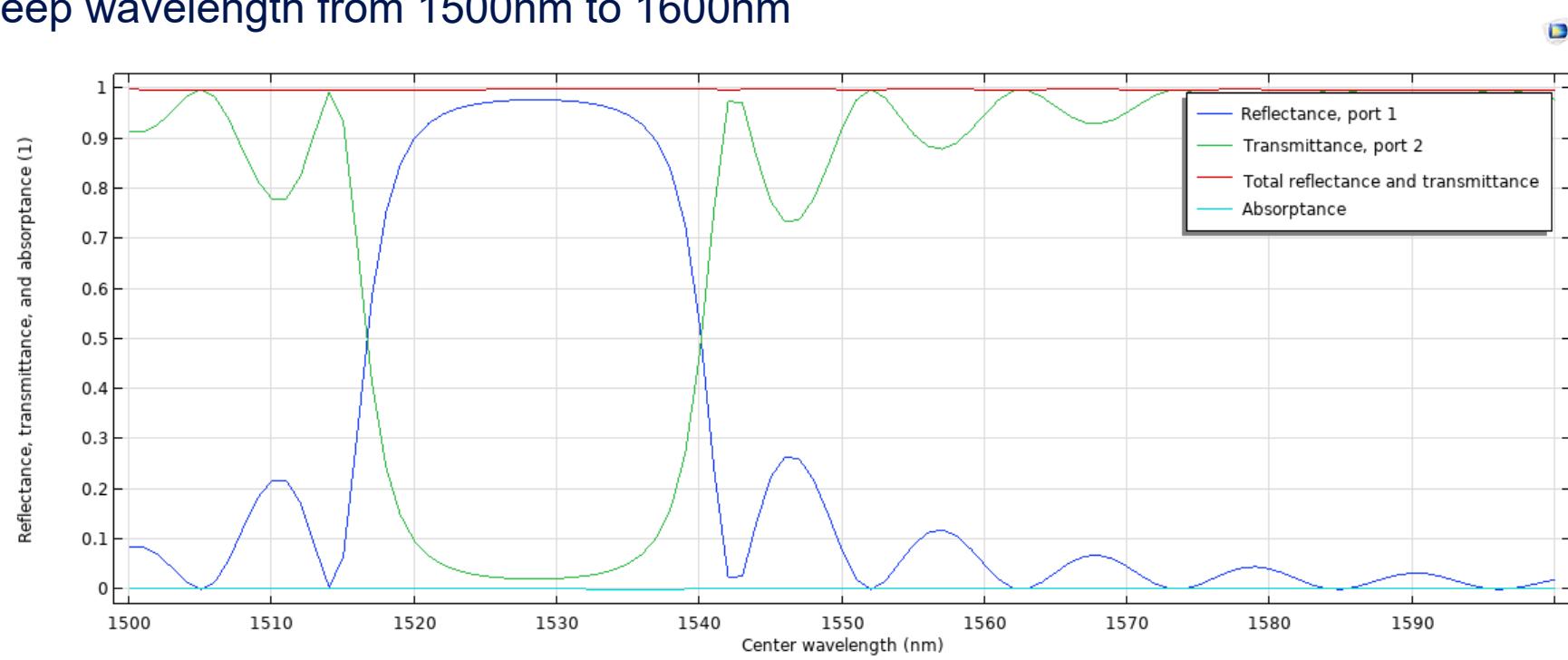


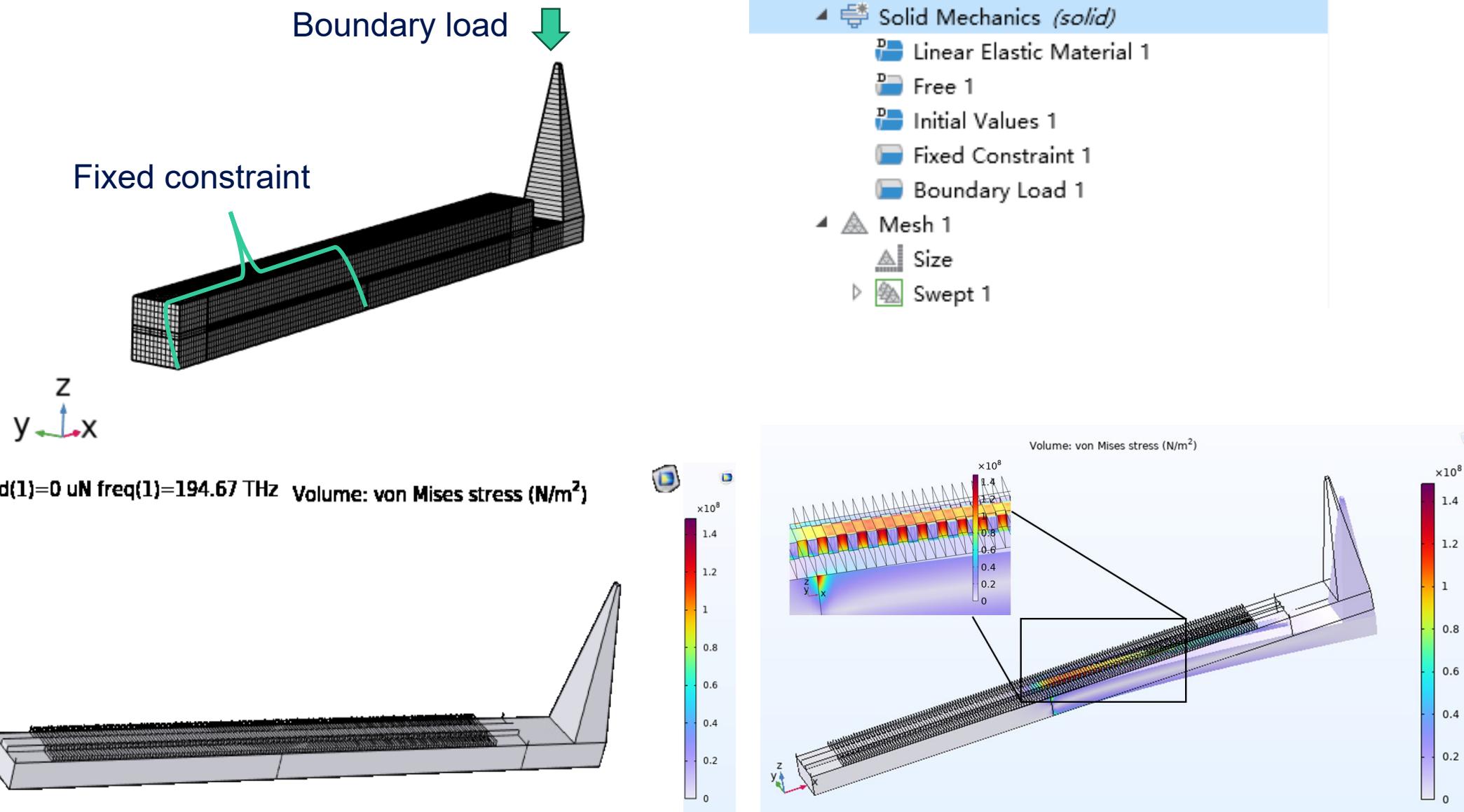
Port 2

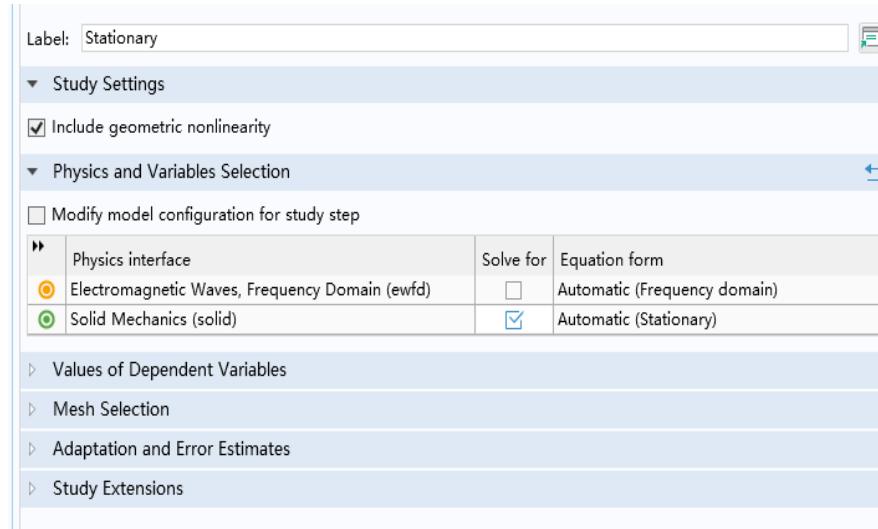
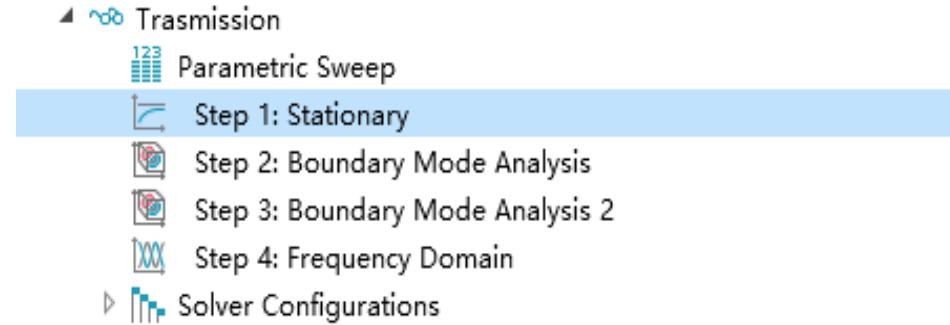




Sweep wavelength from 1500nm to 1600nm



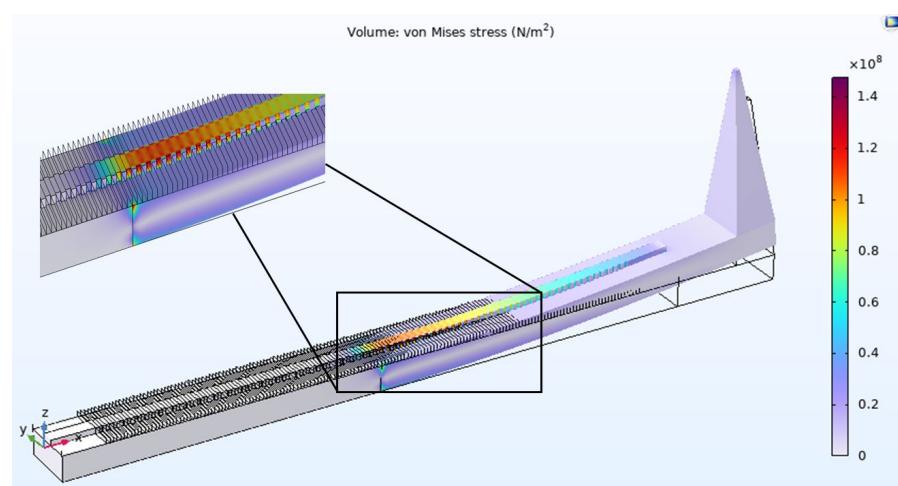
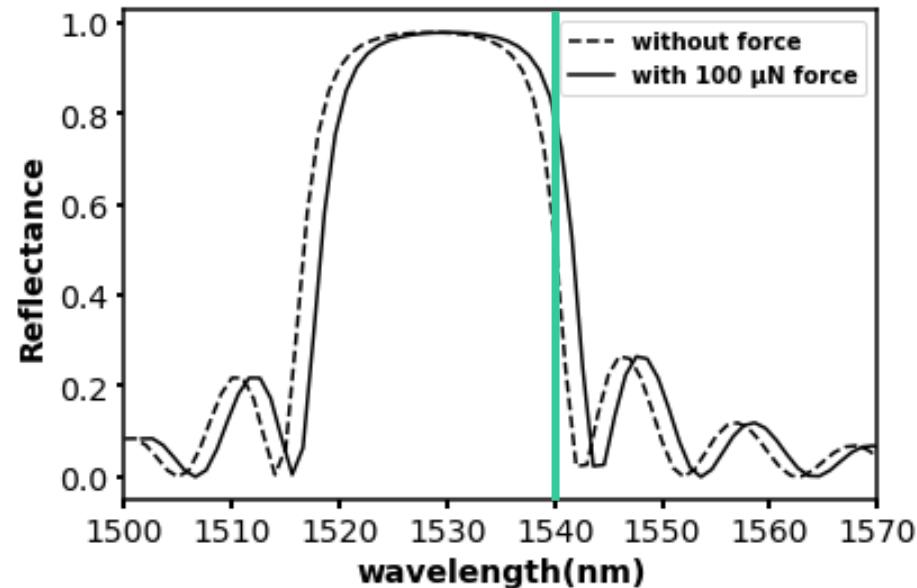




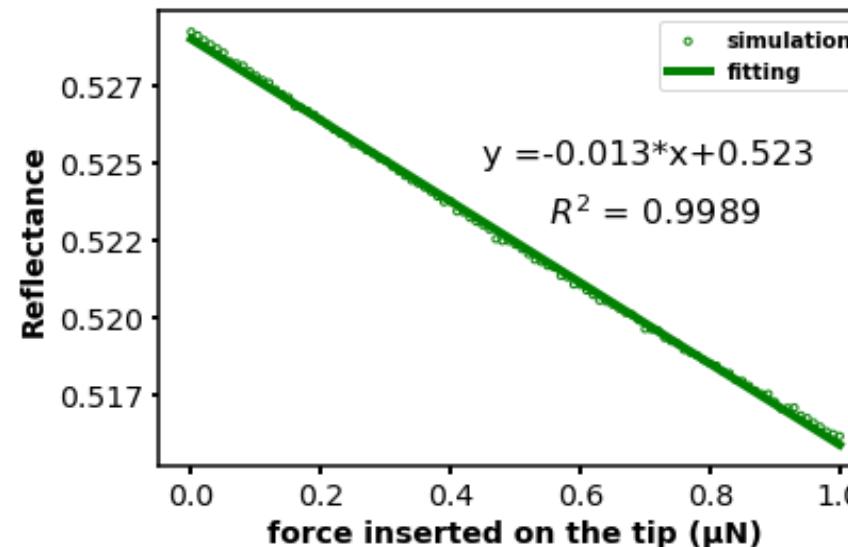
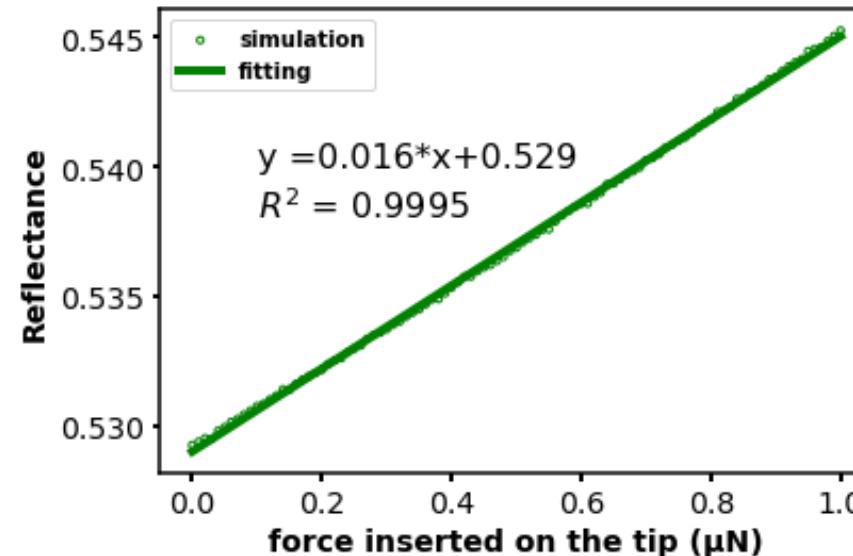
Define refractive index variables for Si, Si_{O₂} and air

Variables			
Name	Expression	Unit	Description
Nx	N=para*(B1*solid.sx+B2*(solid.sy+solid.sz))		Refractive index, x co...
<td>N=para*(B1*solid.sy+B2*(solid.sx+solid.sz))</td> <td></td> <td>Refractive index, y co...</td>	N=para*(B1*solid.sy+B2*(solid.sx+solid.sz))		Refractive index, y co...
Nz	N=para*(B1*solid.sz+B2*(solid.sx+solid.sy))		Refractive index, z co...

Para: 1: stress-optical coupling,
0: no coupling
B1: First stress optical coefficient
B2: Second stress optical coefficient



At wavelength 1540nm



Conclusion

- A 3D Bragg grating-based optomechanical sensor has been designed and simulated in COMSOL.
- Cantilever stiffness is about 0.06 N/m.
- The direction of the applied force by monitoring the increase or decrease in reflected power at the specified wavelength.
- We present the comprehensive 3D coupled finite element analysis aimed at understanding the mechanical stress-induced effects on electromagnetic wave simulations.

Thank you!

Supervisors:

Dr. Georg Ramer

Dr. William Whelan Curtin

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European Union's Horizon 2020 research and innovation programme under the Marie Skłodowska-Curie grant agreement No. 860808

